

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): SORAOKA et al

Serial No.:

Filed: October 21, 2003

For: Vacuum Processing Apparatus And
Semiconductor Manufacturing Line Using
The Same

REAFFIRMATION OF CLAIM FOR PRIORITY

Mail Stop: Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 21, 2003

Sir:

Under the provisions of 35 USC §119 and 37 CFR §1.55, Applicants hereby claim the right of priority based on Japanese Patent Application No. 7-182921, filed in Japan on July 19, 1995.

The certified copy of the above-referred to Japanese Patent Application was filed on October 10, 1996 in prior application Serial No. 08/677,682, filed July 8, 1996.

Respectfully submitted,



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